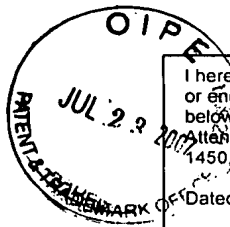


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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as First Class Mail, in an envelope addressed to:
Attention: Certificate of Correction Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Dated: July 19, 2007

Signature

(Anthony G. Sitko)

Docket No.: 29936/37830
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Letters Patent of:
Dae G. Park et al.

Patent No.: 7,157,359

Issued: January 2, 2007

For: METHOD OF FORMING A METAL GATE IN
A SEMICONDUCTOR DEVICE USING
ATOMIC LAYER DEPOSITION

Certificate
JUL 25 2007
of Correction

REQUEST FOR CERTIFICATE OF CORRECTION
PURSUANT TO 37 CFR 1.322

Attention: Certificate of Correction Branch
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Upon reviewing the above-identified patent, Patentee noted a typographical error which should be corrected.

In the Claims:

In the Amendment dated August 29, 2001, page 1, Claim 14, line 2, PTO error, "TiAlN" should be -- TiAlN --.

The error was not in the application as filed by applicant; accordingly no fee is required.

JUL 27 2007

Patent No.: 7,157,359

Docket No.: 29936/37830

Transmitted herewith is a proposed Certificate of Correction effecting such amendment. Patentee respectfully solicits the granting of the requested Certificate of Correction.

Dated: July 19, 2007

Respectfully submitted,

By 

Anthony G. Sitko

Registration No.: 36,278

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JUL 27 2007

**UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION**Page 1 of 1

PATENT NO. : 7,157,359
APPLICATION NO. : 10/036,156
ISSUE DATE : January 2, 2007
INVENTOR(S) : Dae G. Park et al.

It is certified that an error appears or errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

In the Claims:

At Column 6, line 34, "TiaIN" should be -- TiA1N --.

MAILING ADDRESS OF SENDER (Please do not use customer number below):

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Chicago, Illinois 60606-6357

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JUL 27 2007